# 501771207 12/29/2011

#### PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE

#### **CONVEYING PARTY DATA**

Name	Execution Date
The Pennsylvania State University	10/20/2011

#### **RECEIVING PARTY DATA**

Name:	National Science Foundation	
Street Address:	4201 Wilson Blvd	
Internal Address:	Room 1265	
City:	Arlington	
State/Country:	VIRGINIA	
Postal Code:	22230	

### PROPERTY NUMBERS Total: 1

Property Type	Number
Patent Number:	7090889

## **CORRESPONDENCE DATA**

Fax Number: (703)292-9041 Email: nsfpatents@nsf.gov

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

via US Mail.

Correspondent Name: National Science Foundation

Address Line 1: 4201 Wilson Blvd Address Line 2: Room 1265

Address Line 4: Arlington, VIRGINIA 22230

NAME OF SUBMITTER: Robin Clay

Total Attachments: 1 source=161#page1.tif

PATENT 501771207 REEL: 027463 FRAME: 0997

# License to the United States Government

**RECORDED: 12/29/2011** 

Sign and submit the executed document to the appropriate funding agency (e.g. upload in it:dison).
Invention Title: Processing Parameters for Thin Film Deposition of MgB2 on Silicon Substrate
Inventor(s): Z-K. Liu, Z-J. Liu, X. Xi
U.S. Filing/Issue Date: 8/15/06
Patent or Application Serial No.: 7,090,889
Grant/Contract Number(s): N00014-00-1-0294
Foreign Applications filed/intended in (countries):
The invention identified above is a Subject Invention under <b>35 U.S.C. 200, et seq.</b> , and the Standard Patent Rights clause at <b>37 CFR 401.14, FAR 52.227-11</b> or <b>FAR 52.227-12</b> (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:
<ol> <li>The nonexclusive, nontransferable, irrevocable, paid-up license to practice or have practiced for or on behalf of the United States the invention described in any patent application and in any and all divisions, continuations, and continuations in part, and in any and all patents and re-issues granted thereon throughout the world; and</li> <li>All other rights acquired by the Government by reason of the above identified grant/contract award and the laws and regulations that are applicable to the award.</li> </ol>
The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.
Signed this 20th day of October .20 11
By Ronald J. Huss (Institutional Business Official) (Signature)
Title <u>Director, Office of Technology Management</u>
For The Pennsylvania State University (Grantee/Contractor Organization)
At c/o Office of Technology Management
113 Technology Center
University Park, PA 16802 (Business Address)

PATENT REEL: 027463 FRAME: 0998